

Chip-scale Precision Optomechanical Inertial Sensors for GPS-free Navigation

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Limits of GPS & Potential of Precision Inertial Navigation



[1] Satellite in orbit

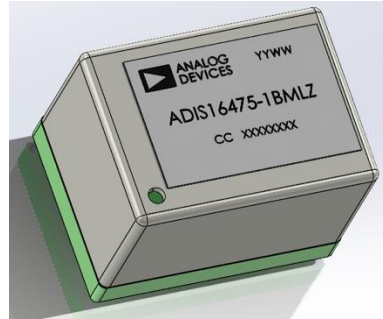
[2] Military Aircraft



- Current ways to track location are not optimized for military use
 - GPS results in external signal transmission
 - INS – Inertial Navigation System
 - Uses both gyroscopes and accelerometers

- Propose an alternative method of measuring location:
 - Optomechanical Accelerometers (OMA)
 - High-sensitivity
 - No outside signals emitted

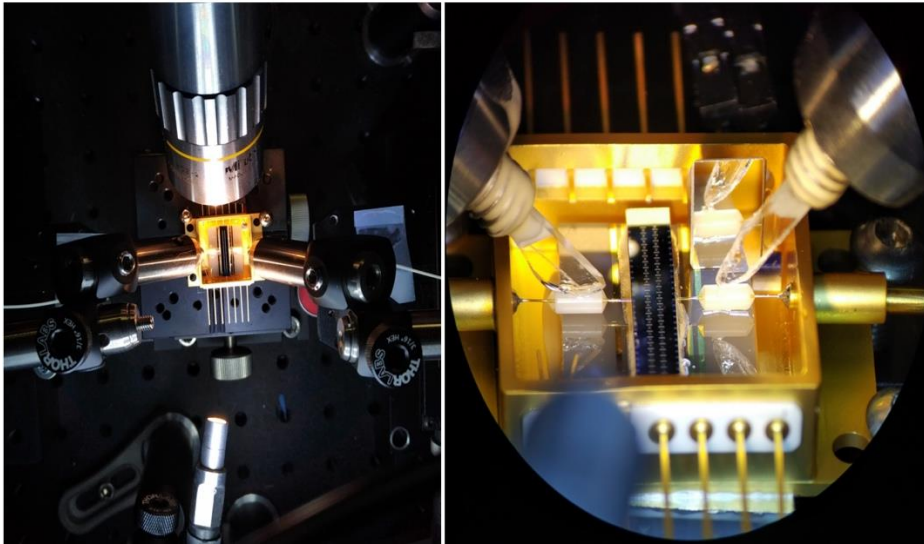
Introduction to Accelerometers & Optomechanical Accelerometers



ADIS16475 - Precision Miniature MEMs IMU



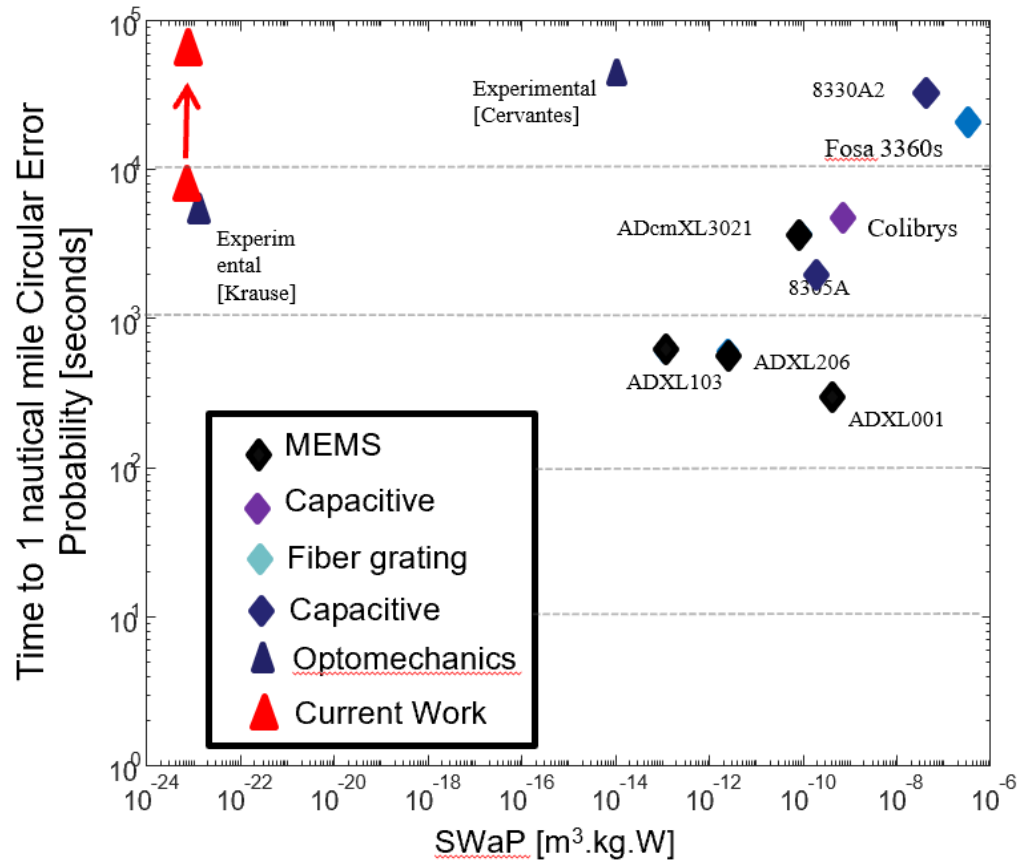
Piezoelectric based accelerometer



Microscope image of nanofabricated optomechanical inertial sensor packaged at UCLA

- Common accelerometers sensing method using Hooke's Law
 - Commercial accelerometers – MEMS, capacitive, and piezoelectric accelerometers
- Optomechanical Accelerometers (OMA)
 - Displacement - measured in mechanical domain
 - Resonant cavity frequency shift - measured in the optical domain
 - Measurement of acceleration found by detecting changes in resonant frequency of the oscillations

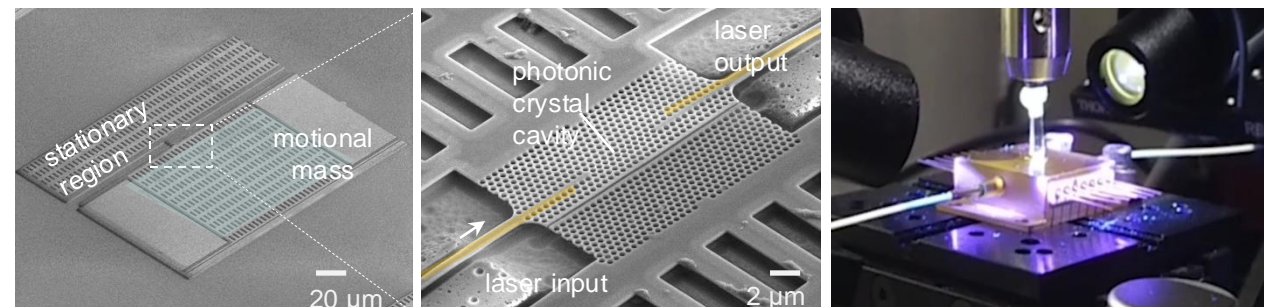
Precision Inertial Navigation: Performance Metrics



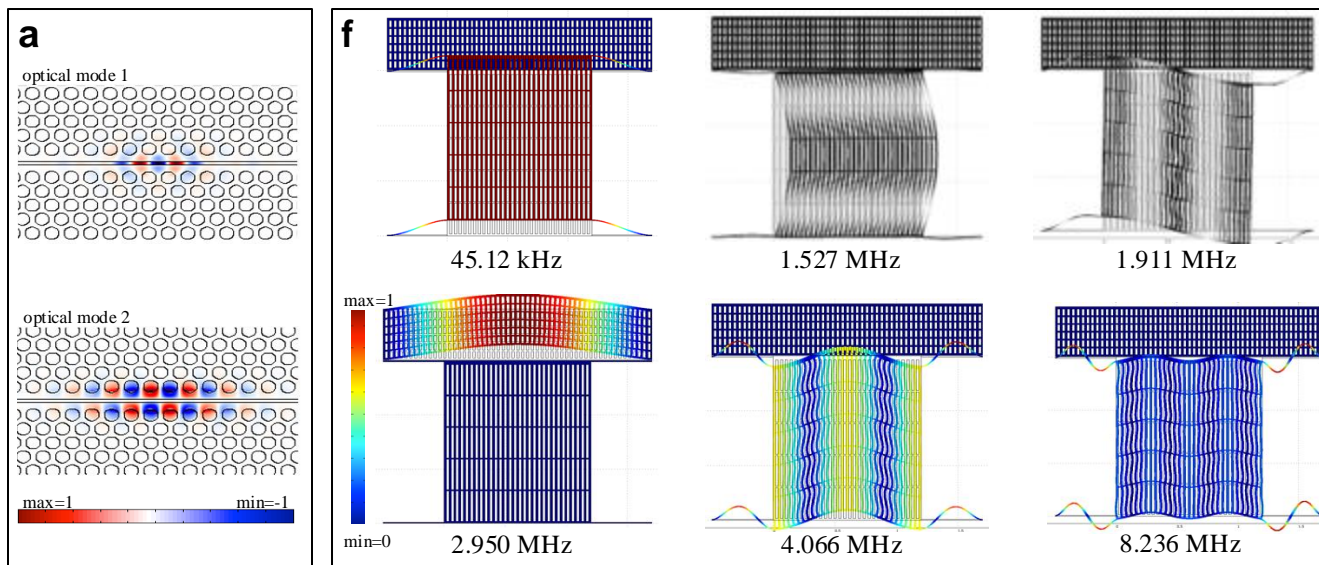
- **Size Weight and Power (SWaP)** - SWaP vs. time to achieve a 1 nautical mile (nmi) error in seconds, for different accelerometers and technologies
- Commercial accelerometers are shown and labeled by model and technology they use
- Optomechanical accelerometers presented in red are our SSTP-STP device modules

Inertial sensor metric	Performance
Volume/Weight	full package 2.8 cm ³ [chiplet is 0.034 cm ³] 31.5 grams [chiplet is 0.08 grams]
Power	58 mW [1-2 W cont. operation of TEC]
Dynamic range	≈30 dB
Velocity random walk	8.2 μg/Hz ^{1/2}
Bias sensitivity	1.3 mg/Hz
Scale factor repeatability	optical resonance repeatability at ~0.7 ppm
Bias instability	52 μg

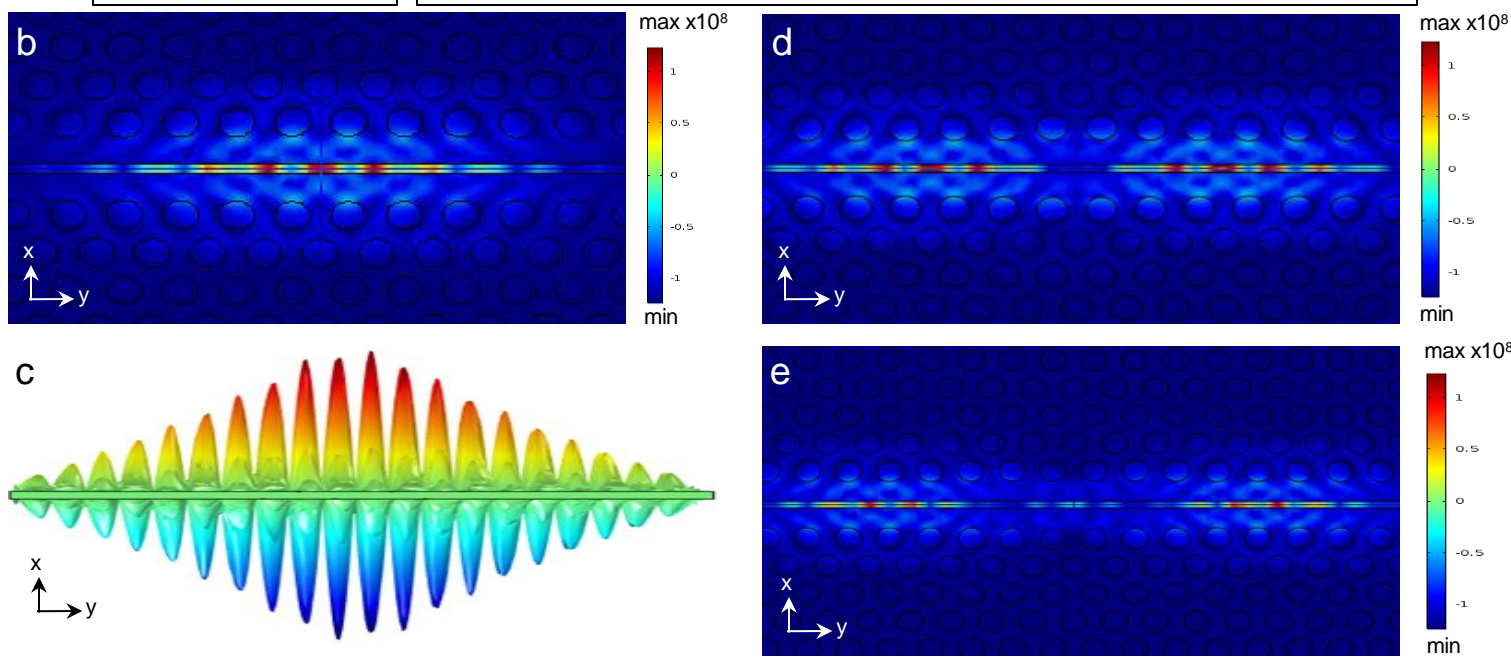
Above: Demonstrated metrics of the chip-scale inertial sensor
Below: Packaged inertial navigation unit with experience from JPL



Inertial Accelerometer: Optical & Mechanical Design



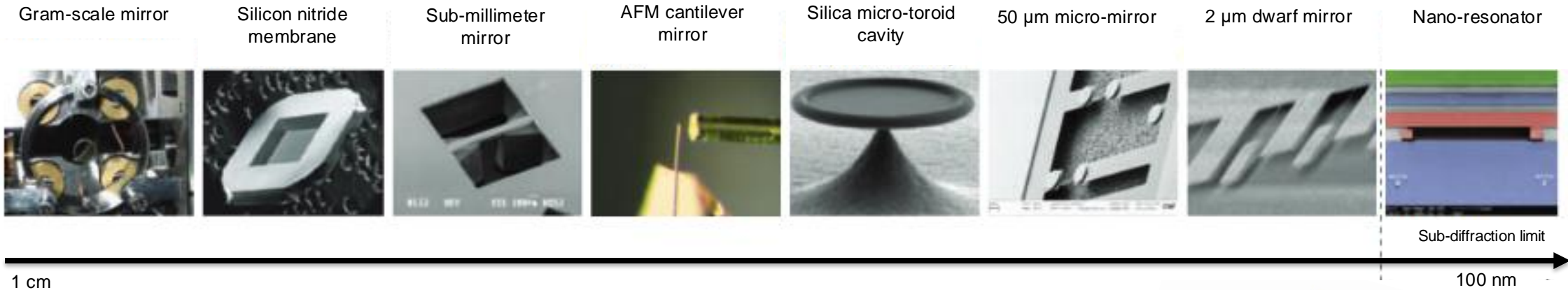
- **Mechanical modes** - designed for the oscillation-mode accelerometer
- Fundamental mode at 45.12 kHz
- Forbidden modes in grey (due to symmetry constraints)
- Finite-element modeling



- **Simulated optical modes** - Figures c-f represent the calculated electric field $(V/m)^2$ of the optical mode for the fully integrated photonic crystal
- **c.** Fundamental mode
- **d.** x-z view of the zoomed in z-component electric field (V/m)
- **e.** Second-order mode
- **f.** Third-order mode

Inertial Navigation: Fundamental Operating Architecture

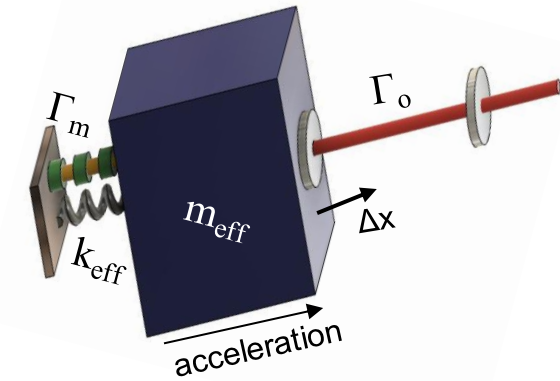
1. Light forces at the Nanoscale



2. Coupled mode and first-order perturbation theory

$$\frac{da}{dt} = i\Delta(x)a - \left(\frac{1}{2\tau_0} + \frac{1}{2\tau_{ex}} \right) a + i\sqrt{\frac{1}{2\tau_{ex}}} s \quad \Delta(x) = \Delta + g_{OM}x = (\omega - \omega_o) + g_{OM}x$$

$$\frac{d^2x}{dt^2} + \frac{\Omega_m}{2Q_m} \frac{dx}{dt} + \Omega_m^2 x = \frac{F_o}{m_{eff}} + \frac{F_{th}}{m_{eff}} = -\frac{|a|^2 g_{OM}}{m_{eff} \omega_0} + \frac{F_{th}}{m_{eff}}$$



To learn more about cavity optomechanics:



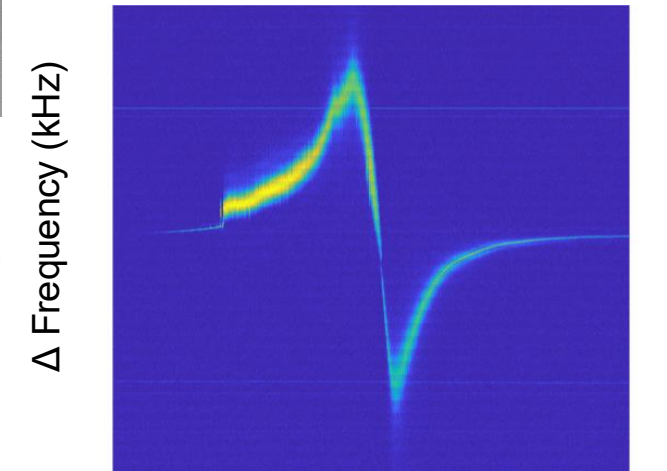
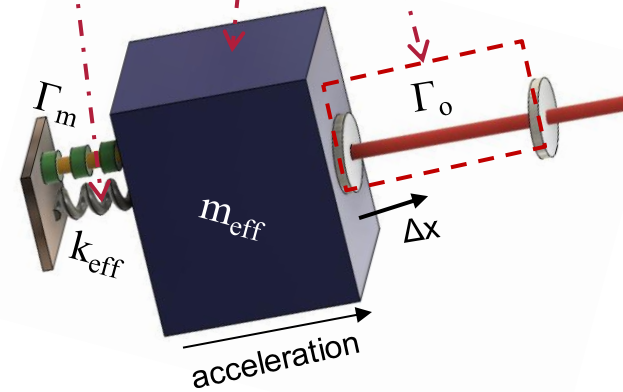
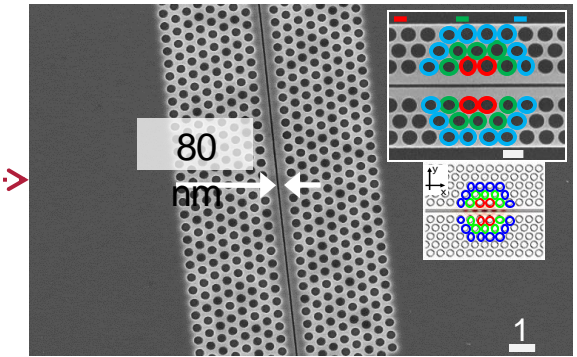
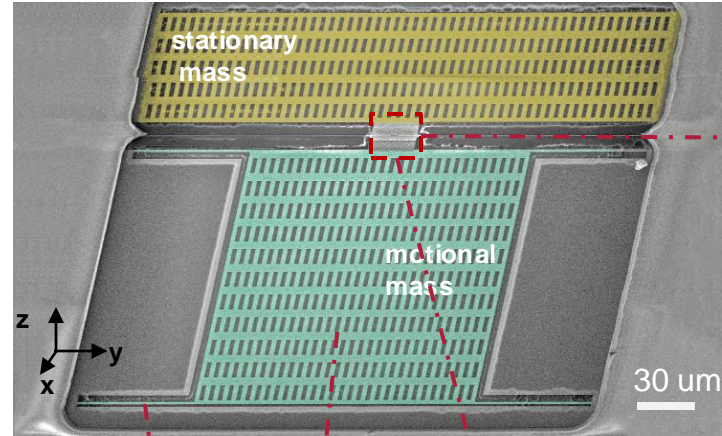
Inertial Navigation: Fundamental Operating Architecture

3. Optomechanical coupling

$$g_{om} = \frac{d\omega}{dx} \quad L_{om}^{-1} = \frac{1}{\omega} \frac{d\omega}{dx}$$

4. First-order perturbation theory

$$g_{om} = \frac{1}{2\omega} \frac{\int dA (\hat{q} \cdot \hat{n}) [\Delta\epsilon |E|^2 - \Delta(\epsilon^{-1}) |D|^2]}{\int dV \epsilon |E(r)|^2}$$



5. Optical spring effect

$$\Omega'_m = \sqrt{\Omega_m^2 + \left(\frac{2|a|^2 g_{om}^2}{(\omega_l - \omega_c + g_{om} x_s)^2 + \left(\frac{\Gamma}{2}\right)^2} \right) (\omega_l - \omega_c + g_{om} x_s) \omega_c m_{eff}}$$

- H. A. Haus, *Waves and Fields in Optoelectronics*.
- S. G. Johnson et al. *Phys. Rev. E* **65**, 066611 (2002).
- C. W. Wong et al. *Appl. Phys. Lett.* **84**, 1242 (2004).
- M. Eichenfield et al. *Optics Express* **17**, 20078 (2009).

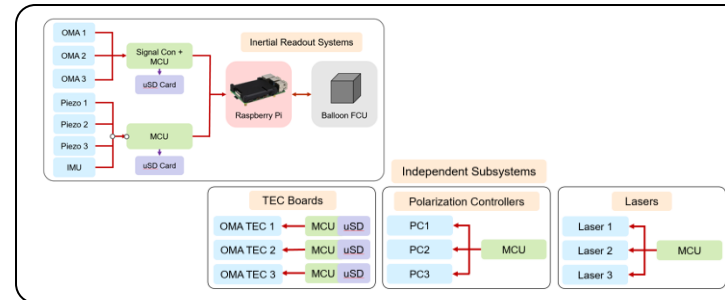
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SSTP: Suborbital Flight Project

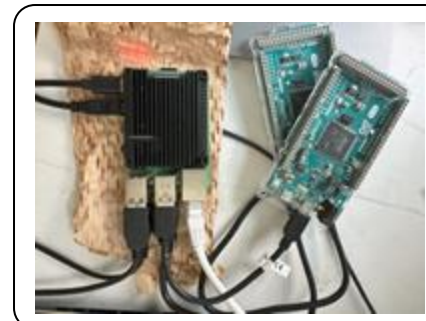
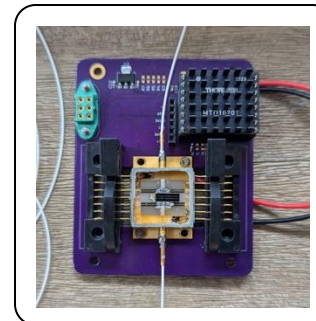
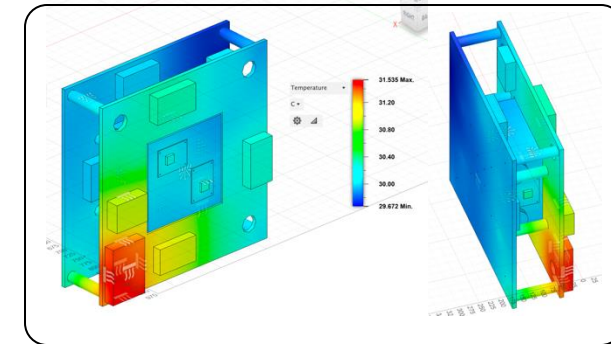


[3] Suborbital Balloon Flight

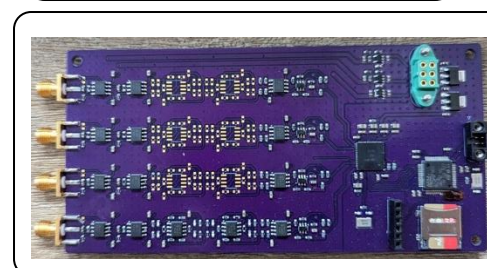
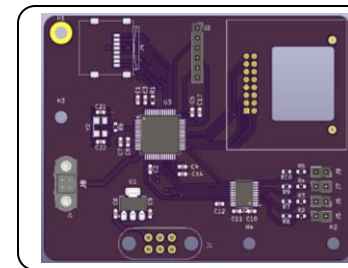
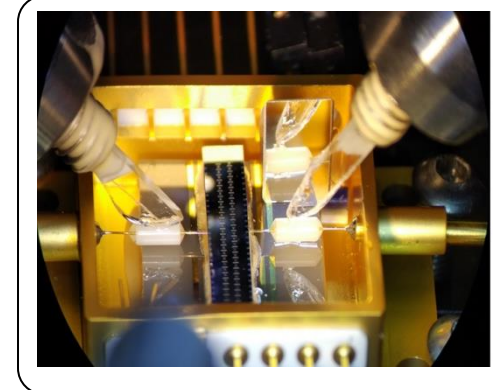


Electronics System Layout

Thermal Simulations



Device Packaging



Electronics System Components & Data Collection